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**TRANSMITTAL LETTER
(General - Patent Pending)**

Docket No.
SEC.910

In Re Application Of: **Kyoung-Hwan CHIN et al.**

Application No.
09/988,302

Filing Date
November 19, 2001

Examiner
Gentle WINTER

Customer No.

Group Art Unit
1746

Confirmation No.
8429

Title: **CLEANING APPARATUS OF A HIGH DENSITY PLASMA CHEMICAL VAPOR DEPOSITION CHAMBER
AND CLEANING METHOD THEREOF**

COMMISSIONER FOR PATENTS:

Transmitted herewith is:

Combined Request for Withdrawal of Finality of Office Action and Amendment Under 35 C.F.R. 1.116

in the above identified application.

- ☒ No additional fee is required.
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**ADAM C. VOLENTINE
REG. NO. 33,289**

**VOLENTINE FRANCOS & WHITT, P.L.L.C.
ONE FREEDOM SQUARE
11951 FREEDOM DRIVE, SUITE 1260
RESTON, VA 20190
TEL. NO. (703) 715-0870**

Dated: **10 September 2004**

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CC:



Serial No. 09/988,302

SEC.910

Amendment dated 10 September 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Kyoung-Hwan CHIN et al.

Group Art Unit: 1746

Serial No.: 09/988,302

Examiner: Gentle WINTER

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CLEANING APPARATUS OF A
HIGH DENSITY PLASMA
CHEMICAL VAPOR DEPOSITION
CHAMBER AND CLEANING
METHOD THEREOF

**COMBINED REQUEST FOR WITHDRAWAL OF
FINALITY OF OFFICE ACTION AND
AMENDMENT UNDER 35 C.F.R. § 1.116**

U.S. Patent and Trademark Office
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Sir:

In response to the Office Action dated 13 July 2004, the period for response to which extends through 13 October 2004, Applicants respectfully traverse the "finality" of the Office Action. Applicants also respectfully request that the above-identified patent application be amended as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.